



Transaction Information

Tool Status	Running Wafer
Wafer Size	300mm
Fab Section	Lithography

General Product Information

Vendor Supplier	ASML
Model	XT1900Gi
Vintage	2008
Asset Description	193mm Immersion Scanner
Software Version	5.1
CIM	SECS
Process	40/45 nm

Hardware Configuration(Fab)

System Type	Description	Quantity	Status
Handler System	wfr handler		OK
Factory Interface	FOUP	1	OK
Others			OK
Options System			OK
Main System	Main Body	1	OK

Excluded Items List(Pumps, Chillers & Abatement are all excluded)

Description	Quantity
NONE	